CLIPPEDIMAGE= JP408178830A

PAT-NO: JP408178830A

DOCUMENT-IDENTIFIER: JP 08178830 A

TITLE: DETECTOR

PUBN-DATE: July 12, 1996

INVENTOR-INFORMATION:

NAME

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SAKATA, MASAKAZU FUJITA, MASAYUKI NISHIO, YOSHITAKA SHIBATA, KENICHI

ASSIGNEE-INFORMATION:

NAME

SANYO ELECTRIC CO LTD

COUNTRY

N/A

APPL-NO: JP06323047

APPL-DATE: December 26, 1994

INT-CL (IPC): G01N015/14

## ABSTRACT:

 $\ensuremath{\operatorname{PURPOSE}}\xspace$  . To determine the size of a particle using a simple optical detection

means by determining the ratio of intensity of light scattering in a plurality

of different directions.

CONSTITUTION: A semiconductor laser (light source) 2 emits laser light

(irradiation light) for irradiating a solution or a gas. A first photodetector

element 3 comprises photodiodes, or the like, arranged on a line connecting the

emitting part of the laser 2 and a quartz container 1. A second photodetector

element 4 comprises photodiodes, or the like, receiving the light backscattering at an angle θ Y. arranged at the angle θ Y with

respect to the central optical axis of laser light emitted from the laser 2 on

the same side as the laser 2 with respect to the container 1. An arithmetic

unit calculates the ratio of intensity of signals outputted from the elements

3, 4 and determines the particle size based on the ratio of

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DERWENT-ACC-NO: 1996-374863

DERWENT-WEEK: 199638

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TITLE: Optical particle detector for measuring particle size

distribution -

has several optical sensors which detects size of irradiated

material from

intensity ratio of scattered light in several direction

PATENT-ASSIGNEE: SANYO ELECTRIC CO LTD[SAOL]

PRIORITY-DATA: 1994JP-0323047 (December 26, 1994)

PATENT-FAMILY:

PUB-NO PUB-DATE LANGUAGE

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APPLICATION-DATA:

PUB-NO APPL-DESCRIPTOR APPL-NO

APPL-DATE

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INT-CL (IPC): G01N015/14

ABSTRACTED-PUB-NO: JP08178830A

BASIC-ABSTRACT: The detector includes a semiconductor laser (2)

which

irradiates a light to an irradiated material (1). The irradiated

scatters the irradiated light and produces an incidence angle in several

directions.

The produced incidence angle which differs mutually is detected by several

optical sensors (3,4). The size of the irradiated material is detected by the

optical sensors from the intensity ratio of the scattered light in several directions.

ADVANTAGE - Reduces optical particle detector cost due to eliminated complex

optical sensor. Accurately detects size of irradiated material

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from intensity
ratio of scattering light accurately. Ensures irradiated
material with
improved size detection sensitivity. Prevents direct projection
of irradiated
light in optical detector.

CHOSEN-DRAWING: Dwg.1/2

TITLE-TERMS:

. . .

OPTICAL PARTICLE DETECT MEASURE PARTICLE SIZE DISTRIBUTE OPTICAL SENSE DETECT
SIZE IRRADIATE MATERIAL INTENSITY RATIO SCATTERING LIGHT DIRECTION

DERWENT-CLASS: S03

EPI-CODES: S03-E04C; S03-F05C; S03-F06C;

SECONDARY-ACC-NO:

Non-CPI Secondary Accession Numbers: N1996-315484

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